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Docket No.: 2336-254

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Sun Woon KIM *et al.* : Confirmation No. 2939

U.S. Patent Application No. 10/806,432 : Group Art Unit: 2815

Filed: March 23, 2004 : Examiner: Allan R. Wilson

For: **FABRICATION METHOD OF NITRIDE SEMICONDUCTORS AND NITRIDE SEMICONDUCTOR STRUCTURE FABRICATED THEREBY****RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Sir:

By Official Action mailed May 12, 2005, restriction to one of the following inventions is required:

Group I: Claims 12 and 13, drawn to a semiconductor device, classified in class 257, subclass 347.

Group II: Claims 1-11, drawn to a method of making a semiconductor device, classified in class 438, subclass 149.

In response, Applicants hereby elect Group II, upon which claims 1-11 are readable.

The election is made *with traverse* because the search and examination of the entire application can be made without serious burden. Inventions II and I are related as process of

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making and product made. In the relevant art, i.e., semiconductor device design and fabrication, references often describe both the semiconductor device's structure and manufacturing method, as will be apparent to the Examiner upon conducting a search for prior art. Therefore, both Inventions I and II can be covered in a single search. Accordingly, Applicants respectfully submit that the search and examination of the entire application can be made without serious burden on the Examiner.

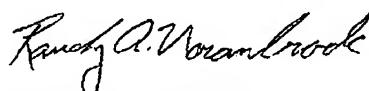
In view of the above, withdrawal of the Restriction Requirement and consideration of all claims pending in the instant application are believed appropriate and therefore courteously solicited.

Early examination on the merits is courteously solicited.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,

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CERTIFICATION OF FACSIMILE TRANSMISSION  
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE ON THE DATE SHOWN BELOW

*R. Bryant*  
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